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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/678,899	10/02/2003	Joseph Consolini	6601P033	2351	
8791 7	590 06/01/2006		EXAMINER		
BLAKELY SOKOLOFF TAYLOR & ZAFMAN			EDWARDS, LAURA ESTELLE		
12400 WILSH SEVENTH FL	IRE BOULEVARD OOR		ART UNIT	PAPER NUMBER	
LOS ANGELE	ES, CA 90025-1030		1734		
			DATE MAILED: 06/01/2000	6	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Applica	tion No.	Applicant(s)				
Office Action Summary		10/678,	899	CONSOLINI ET A	CONSOLINI ET AL.			
		Examin	er	Art Unit				
		Laura E	dwards	1734				
Period fo	The MAILING DATE of this commun or Reply	ication appears on t	he cover sheet w	vith the correspondence a	ddress			
A SH WHIC - Exter after - If NC - Failu Any	ORTENED STATUTORY PERIOD F CHEVER IS LONGER, FROM THE M nsions of time may be available under the provisions SIX (6) MONTHS from the mailing date of this common period for reply is specified above, the maximum street or reply within the set or extended period for reply reply received by the Office later than three months and patent term adjustment. See 37 CFR 1.704(b).	IAILING DATE OF To so of 37 CFR 1.136(a). In no enunication. atutory period will apply and a will, by statute, cause the all	THIS COMMUNI event, however, may a will expire SIX (6) MO polication to become A	ICATION. reply be timely filed NTHS from the mailing date of this of BANDONED (35 U.S.C. § 133).				
Status								
1)⊠	Responsive to communication(s) file	ed on 3/30/06.						
2a)□	•	2b)⊠ This action is	non-final.					
3)								
٧,١	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Dispositi	on of Claims							
4)⊠	☑ Claim(s) <u>1-5,8 and 28-38</u> is/are pending in the application.							
•	4a) Of the above claim(s) is/are withdrawn from consideration.							
5)🖾	Claim(s) <u>1-5,8,28 and 30-34</u> is/are allowed.							
6)🖂	Claim(s) <u>29 and 35-37</u> is/are rejected.							
7)⊠	Claim(s) 38 is/are objected to.							
8)	Claim(s) are subject to restrict	ction and/or election	requirement.					
Applicati	on Papers							
9)	The specification is objected to by th	e Examiner.						
,	The drawing(s) filed on is/are		o) objected to	by the Examiner.				
,—	Applicant may not request that any obje							
	Replacement drawing sheet(s) including				FR 1.121(d).			
11)	The oath or declaration is objected to	b by the Examiner.	Note the attache	d Office Action or form P	TO-152.			
Priority ι	ınder 35 U.S.C. § 119							
	Acknowledgment is made of a claim All b) Some * c) None of: 1. Certified copies of the priority 2. Certified copies of the priority	documents have be	een received.					
	3. Copies of the certified copies	of the priority docun	nents have beer	n received in this Nationa	l Stage			
	application from the Internation	onal Bureau (PCT R	ule 17.2(a)).					
* 9	See the attached detailed Office action	on for a list of the ce	rtified copies no	t received.				
Attachmen	t(s)		_					
	e of References Cited (PTO-892)			Summary (PTO-413)				
3) 🔲 Infor	e of Draftsperson's Patent Drawing Review (F nation Disclosure Statement(s) (PTO-1449 or r No(s)/Mail Date			o(s)/Mail Date f Informal Patent Application (PTO-152) 				

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Claim Rejections - 35 USC § 112

Claims 29 and 35-38 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

In claim 29, line 2, "the recovery drain" lacks antecedent basis.

In claim 35, page 5, lines 1-2, Applicants recite the use of the system to recover one or more additional types of photoresists and it is unclear how additional (i.e., of a different type) photoresist can be recovered when one a single photoresist is supplied to the system via the nozzle.

In claim 35, page 5, lines 1-2, Applicants recite corresponding photoresist recovery containers and it is unclear whether these containers are a part of the claimed invention used in addition to the previously claimed photoresist recovery container or whether these additional recovery containers are only intended to be used with the system (merely functional language) but form no basis of the invention. Clarification is necessary.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 35 and 36 are rejected under 35 U.S.C. 102(b) as being anticipated by Yamauchi et al (PAPUS2002/0112662).

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Yamauchi et al disclose a system for photoresist recovery comprising at least one nozzle ([0032]) to dispense photoresist, a bowl (11) having an interior region and an interior surface; a wafer platform and spindle ([0032]; lines 1-9) disposed within the interior region of the bowl, the wafer spindle coupled to the wafer platform to spin the wafer platform to propel an excess amount of photoresist deposited upon a wafer placed upon the wafer platform to the interior surface of the bowl; a photoresist recovery container or cup (19); a first perimeter drain (area 15, 19) formed within the bowl such that the excess amount of photoresist propelled from the wafer proceeds through the perimeter drain to the photoresist recovery container, a vertically disposed waste drain (i.e., area 16), and a second perimeter drain (12) formed about the bowl to recover photoresist. Yamauchi et al provide an additional photoresist recovery container or cup (20). Applicants intended use of the system to process plural photoresists into corresponding recovery containers has been given no patentable because only a single photoresist is delivered or supplied to the system.

With respect to claim 36, see [0033] wherein the chuck and evidently the shaft is adjustable.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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The factual inquiries set forth in *Graham* v. *John Deere Co.*, 383 U.S. 1, 148 USPQ 459 (1966), that are applied for establishing a background for determining obviousness under 35 U.S.C. 103(a) are summarized as follows:

- 1. Determining the scope and contents of the prior art.
- 2. Ascertaining the differences between the prior art and the claims at issue.
- 3. Resolving the level of ordinary skill in the pertinent art.
- 4. Considering objective evidence present in the application indicating obviousness or nonobviousness.

Claim 37 is rejected under 35 U.S.C. 103(a) as being unpatentable over Yamauchi et al (PAPUS2002/0112662) in view of Yamasaka (US 5,997,653).

The teachings of Yamauchi et al have been mentioned above but Yamauchi et al are silent concerning the bowl being adjustable relative to the wafer platform. However, it was known in the art, at the time the invention was made, to provide an adjustable/movable bowl relative to a wafer platform to facilitate cleaning/rinsing of the wafer as evidenced by Yamasaka (col. 5, lines 64 to col. 6, lines 1-10 and col. 7, lines 19-29). It would have been obvious to one of ordinary skill in the art to incorporate an adjustable bowl as taught by Yamasaka in the Yamauchi et al system in order to facilitate cleaning/rinsing of a treated wafer.

Allowable Subject Matter

Claims 1-5, 8, and 28, and 30-34 are allowable.

Claim 38 is objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

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Claim 29 would be allowable if rewritten to overcome the rejection(s) under 35 U.S.C. 112, 2nd paragraph, set forth in this Office action and to include all of the limitations of the base claim and any intervening claims.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Laura Edwards whose telephone number is (571) 272-1227. The examiner can normally be reached on Monday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Chris Fiorilla can be reached on (571) 272-1187. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Laura Edwards
Primary Examiner
Art Unit 1734

Le May 26, 2006